

New Interfacial Shear-Horizontal Waves in Piezoelectric Cubic Crystals

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ABSTRACT

This theoretical study reports results on acoustic wave propagation along the interface of two half-spaces representing cubic crystals of both piezoelectric classes $\overline{43}m$ and 23 with strong piezoelectric effect. In similar configurations, the interfacial Maerfeld-Tournois waves can propagate along the interface of two transversely-isotropic materials of class 6 mm, in which the shear-horizontal surface acoustic waves (SH-SAWs) called the Bleustein-Gulyaev (BG) waves can also exist. Cubic piezoelectrics cannot support existence of the surface BG-waves, according to the recent report by Gulyaev and Hickernell. Hence, new interfacial SH-waves are studied in this paper concerning unique direction [101] of wave propagation in cubic crystals using different electrical boundary conditions (EBCs) of both metallized and non-metallized interfaces. The new interfacial SH-waves can always propagate along the interface of two identical piezoelectrics. It was also found that the new interfacial SH-waves can exist when wave propagation is along the interface of two dissimilar half-spaces, for instance, the piezoelectric cubic crystals Bi₁₂SiO₂₀ and Bi₁₂GeO₂₀. Several calculations are also carried out as examples. **PACS:** 51.40.+p, 62.65.+k, 68.35.Gy, 68.35.Iv, 68.60.Bs, 74.25.Ld.

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1. Introduction

The theoretical investigations carried out in 1971 by Maerfeld and Tournois [1] introduced an acoustic shear-horizontal (SH) wave guided by the common interface of two semi-infinite media, if at least one of the media is a piezoelectric material. Maerfeld and Tournois have stated the existence conditions for such waves called the interfacial Maerfeld-Tournois (MT) waves, which can also propagate along the interface of two identical transversely-isotropic crystals of class 6 mm, when the C-axes of the crystals are in opposite directions, satisfying the perpendicularity condition of the wave propagation direction to an even-order symmetry axis. This is similar to the other shear-horizontal surface acoustic waves (SH-SAWs) simultaneously discovered by Bleustein [2] and by Gulyaev [3] in the late 1960s, which possess a hybridization between the mechanical displacement U_2 and electrical potential $\varphi = U_4$. These two types of SH-waves, namely the interfacial MT-waves and surface Bleustein-Gulyaev (BG) waves, can only propagate along surfaces of suitable crystal cuts of transversely-isotropic crystals of the hexagonal and tetragonal classes 6 mm and 4 mm. It is thought that these surface SH-waves have deeper penetration length and lower energy loss than do surface Rayleigh waves [4]. Therefore, they can be easily excited and detected.

The recent work [5] by Gulyaev and Hickernell noted impossibility of SH-SAW existence in piezoelectric cubic crystals. In addition, Ref. [6] discussed that SH-SAWs on electrically open or shorted surfaces of piezoelectric crystals of classes 622 and 422 cannot exist if the propagation direction is perpendicular to six or four-fold axes. However, the surface BG-waves can be found as soon as the transversely-isotropic symmetry decreases from class 622 to 6 or from class 422 to 4. It is noted that both the surface BG-wave and interfacial electro-acoustic MTwave may be caused by interfacial crack propagation between two dissimilar piezoelectric crystals.

The purpose of this report is to introduce theoretical investigations of new interfacial SH-waves in piezoelectric cubic crystals with the strong piezoelectric effect. The Chalcogenide family crystals $(Tl_3VS_4 \text{ and } Tl_3TaSe_4)$ [7]) belonging to the cubic class $\overline{43m}$ and possessing both zero temperature coefficients and strong piezoelectric coupling, are examined. In spite of their very large potential interest, especially for moderate frequency and large bandwidth, such ternary thallium Chalcogenides Tl₃TaSe₄ are not commercially available, probably due to their mechanical softness and fabrication difficulties. However, the piezoelectric ceramics of the point group symmetry 23 (Bi₁₂SiO₂₀ and Bi₁₂GeO₂₀ [8] and Bi₁₂TiO₂₀ [9]) can be used in piezoelectronics. Recently, new SH-SAWs [10] called the ultrasonic surface Zakharenko waves (USZWs) were discovered in such cubic piezoelectrics with the strong piezoelectric effect. Note that some piezoelectrics display colossal enhancement of piezoelectricity [11]. It is noted that over several hundred piezoelectric materials, particularly piezoelectric ceramics or composites, are known, for example see Ref. [12], having their intrinsic electromechanical coupling behaviors. They are widely used today for different applications such as filters and sensors, as well as actuators and ultrasonic generators.

Concerning fabrication of a structure consisting of two dissimilar crystals, a process called wafer bonding is utilized in the semiconductor industry, allowing two different materials to be rigidly and permanently bonded along a plane interface, thus producing a composite bi-material [13]. It is noted that several hundred wafer bonding patents are annually deposited [14]. In addition, a similar second process called fusion bonding is used by the polymer industry to bring together two parts of different solid polymers, thus enabling the manufacture of a heterogeneous bi-material with specific properties [15,16]. In the first process, wafers of two different crystals are stuck together through Van der Waals forces, after their surface has been mirror-polished. In the second, however, a fusion process followed by a cooling and consolidating period takes place at the interface. It is obvious that it is important to be able to inspect the strength of the bonding, possibly through non-destructive ultrasonic evaluation. However, very few simple numerical investigations exist to compute the speed, etc., of interfacial waves when they exist.

2. Theory

Figure 1 introduces a rectangular coordinate system (x_1, x_2, x_3) so that the x_1Ox_3 sagittal plane is perpendicular to the even-order symmetry axis of a piezoelectric cubic crystal and the x_1 -axis demonstrates wave propagation in



Figure 1. The rectangular coordinate system with the x_2 -axis directed along the interface of two half-spaces where the x_1 -axis is directed perpendicular to the figure plane.

direction [101]. It is necessary to write governing equations of linear piezoelasticity. Constitutive relations are written as follows:

$$T_{ij} = C^E_{ijkl} S_{kl} - e_{ijm} E_m \tag{1}$$

$$D_m = e_{mij} S_{ij} + g_{mn} E_n \tag{2}$$

in which T_{ij} and S_{ij} are the stress and strain tensors, respectively; D_m and E_m are components of the electrical displacement and electrical field ($E_m = -\partial \varphi / \partial x_m$ where φ is the electrical potential); the indices i, j, k, l, m, and n run from 1 to 3. According to the Voigt notation, C_{ijkl} , e_{ijm} , and g_{mn} can be written as 6×6 , 3×6 , and 3×3 matrices standing for the elasticity, piezoelectricity, and dielectricity tensors, respectively. It is assumed that studied materials are free of body forces and inertial effects as well as body electric charge. The equilibrium equations are as follows: $\partial T_{ij}/\partial x_i = 0$ and $\partial D_i/\partial x_i = 0$.

The equation of motion of an elastic medium is written as follows:

$$\frac{\partial T_{ik}}{\partial x_k} = \rho \frac{\partial^2 U_i}{\partial t^2} \tag{3}$$

where ρ and U_i denote the mass density and mechanical displacement components; *t* is time. Using equations from (1) to (3), the coupled equations of motion for a piezoelectric medium are written in the following forms:

$$C_{ijkl} \frac{\partial^2 U_l}{\partial x_j \partial x_k} + e_{kij} \frac{\partial^2 U_4}{\partial x_j \partial x_k} = \rho \frac{\partial^2 U_i}{\partial t^2}$$

$$e_{ijk} \frac{\partial^2 U_k}{\partial x_i \partial x_j} - g_{ij} \frac{\partial^2 U_4}{\partial x_i \partial x_j} = 0$$
(4)

with $U_4 = \varphi$. Solutions of the homogeneous partial differential Equation (4) of the second order are found in the following plane wave form:

$$U_{i} = U_{i}^{0} \exp\left[jk\left(n_{1}x_{1} + n_{2}x_{2} + n_{3}x_{3}\right) - j\omega t\right]$$

where the index *i* runs from 1 to 4; U_i^0 is an initial amplitude. The imaginary unity is defined as $j = (-1)^{1/2}$ and ω is the angular frequency. k is the wavenumber in the k-space with the following components $\{k_1, k_2, k_3\} = k\{n_1, k_2, k_3\}$ n_2, n_3 and $\{n_1, n_2, n_3\}$ are the directional cosines. $\{x_1, x_2, x_3\}$ x_3 are the components of real space.

Leaving only equations for waves with polarization perpendicular to the sagittal plane and non-zero components of the material tensors, the coupled equations of motion in Equation (4) can then be written in the following convenient forms:

$$C_{44}\left(\frac{\partial^2 U_2}{\partial x_1^2} + \frac{\partial^2 U_2}{\partial x_3^2}\right) + e_{16}\frac{\partial^2 U_4}{\partial x_1^2} + e_{34}\frac{\partial^2 U_4}{\partial x_3^2} = \rho \frac{\partial^2 U_2}{\partial t^2}$$
$$e_{16}\frac{\partial^2 U_2}{\partial x_1^2} + e_{34}\frac{\partial^2 U_2}{\partial x_3^2} - g_{11}\left(\frac{\partial^2 U_4}{\partial x_1^2} + \frac{\partial^2 U_4}{\partial x_3^2}\right) = 0$$
(5)

where the mechanical displacement component U_2 is directed along the x_2 -axis shown in **Figure 1**:

$$U_{2,4} = U_{2,4}^0 \exp\left[jk\left(n_1x_1 + n_3x_3 - V_{ph}t\right)\right]$$
(6)

In Equation (6), the phase velocity is defined as $v_{ph} =$ ω/k . Equation (5) describes wave propagation in direction [101] with $e_{14} = e_{36} = 0$ and the non-zero piezoelectric constants $\{e_{16}, e_{34}\}$. It is thought that such cuts of cubic crystals can be readily done. Note that all propagation directions perpendicular to direction [010] can exist giving $C_{44} = C_{66}$ and $g_{11} = g_{33}$ concerning piezoelectric cubic crystals.

Using Equations (5) and (6), the tensor form of equations of motion can be written with corresponding GL-components in the Green-Christoffel equations: $GL_{22} = C_{44} \left(1 + n_3^2 \right)$, $GL_{24} = GL_{42} = e_{16} + e_{34} + e_{34}n_3^2$ and $GL_{44} = -g_{11}(1+n_3^2)$ where $n_3 = k_3/k$. Therefore, the following system of two homogeneous equations must be resolved:

$$\begin{pmatrix} GL_{22} - C_{44} \left(V_{ph} / V_{t4} \right)^2 & GL_{24} \\ GL_{42} & GL_{44} \end{pmatrix} \begin{pmatrix} U_2^0 \\ U_4^0 \end{pmatrix} = \begin{pmatrix} 0 \\ 0 \end{pmatrix}$$
(7)

The directional cosines in Equation (7) are defined as follows: $n_1 \equiv 1$, $n_2 \equiv 0$ and $n_3 = n_3$. Setting the determinant of the coefficient matrix in Equation (7) equal to zero, several characteristics can be found such as a suitable phase velocity V_{ph} satisfying boundary conditions discussed in the following section and four polynomial roots $n_3^{(p)}(V_{ph})$, as well as the functions $U_2^{0}(V_{ph})$ and $U_4^{0}(V_{ph})$. It is thought that it is convenient to utilize the functions $U_2^0(V_{ph})$ and $U_4^0(V_{ph})$ in the following forms:

 $U_4^0 = GL_{42}$ and $U_2^0 = -GL_{44}$. Using the piezoelectric constants $e_{16} = -e_{34}$ for direction [101], the following polynomial can be introduced from Equation (7):

$$(1+K_e^2)m_3^2 - Bm_3 + 4K_e^2 = 0$$
 with $B = \left(\frac{V_{ph}}{V_{t4}}\right) + 4K_e^2$ (8)

where $m_3 = 1 + n_3^2$. In Equation (8), K_e^2 is the static coefficient of the electromechanical coupling (CEMC): $K_e^2 = e_{16}^2 / (C_{44}g_{11})$. Note that the speed V_{SH} of the bulk SH-wave reads:

$$V_{SH} = V_{t4} \left(1 + K_e^2 \right)^{1/2} \tag{9}$$

It is obvious that Equation (8) has two roots:

$$m_{3}^{(1,2)} = \frac{B \pm \sqrt{B^{2} - 16K_{e}^{2} \left(1 + K_{e}^{2}\right)}}{2\left(1 + K_{e}^{2}\right)}$$
(10)

Hence, four polynomial roots (eigenvalues) of Equation (7) are as follows:

$$n_3^{(1,2,3,4)} = \pm \sqrt{-1 + m_3^{(1,2)}} \tag{11}$$

It is noted that the eigenvector $\{U_2^0, U_4^0\}$ in Equation (7) can be obtained for each eigenvalue n_3 .

Note that all complex roots can be calculated when the expression $B^2 - 16K_e^2(1 + K_e^2)$ under square root in Equation (10) is negative. This fulfills for $V_{ph} < V_K$ obtained from the following equation $B^2 - 16K_e^2(1 + K_e^2) =$ 0 and defined by the following formula:

$$V_{K} = \alpha_{K} V_{t4}$$
 with $\alpha_{K} = 2\sqrt{K_{e}\sqrt{1 + K_{e}^{2} - K_{e}^{2}}}$ (12)

It is clearly seen that both the factor α_K in Equation (12) and the function $f(K_e^2) = (1 + K_e^2)^{1/2}$ in Equation (9) are functions of the CEMC K_e^2 . Discussions about behavior of polynomial roots and the function α_k can be found in Ref. [10]. However, it is necessary to briefly discuss that only complex polynomial roots can exist for $V_{ph} < V_K$ and that for $K_e^2 < K_0^2$ ($K_0^2 = 1/3$) there are all imaginary roots for $V_{ph} > V_K$, but a very large $K_e^2 > K_0^2$ gives real roots for $V_{ph} > V_K$. It is noted that only complex/imaginary roots with negative/positive imaginary parts for medium I/II in Figure 1 are chosen in order to have wave damping towards the each half-space depth from the common interface. Probably, surface waves cannot be found in the cubic crystals with a large $K_e^2 > 1/3$ in the V_{ph} -range: V_K $< V_{ph} < V_{SH}$. It is thought that a large K_e^2 can be observed in complex compounds, as well as in simple materials including piezoelectric cubic crystals. For instance, a single ferroelectric tetragonal (T) to paraelectric cubic phase transition is observed in the classic ferroelectric PbTiO₃ with increase in temperature or pressure, according to the recent results obtained in Ref. [11].

3. Boundary Conditions for Interfacial SH-Waves

There is single boundary at $x_3 = 0$ in **Figure 1** representing the interface between two half-spaces, at which suitable requirements can be chosen. These several requirements called boundary conditions must be satisfied for propagation of the interfacial SH-waves, which must damp from the common interface towards depth of each half-space. Using the coordinate system in **Figure 1**, only eigenvalues with negative imaginary parts must be chosen for the medium with negative values of the x_3 -axis. Also, only eigenvalues with positive imaginary parts must be chosen for the medium with $x_3 > 0$. There are two mechanical boundary condition such as equality of the mechanical displacements $U_2 (U_2^{-1} = U_2^{-1})$ where

$$U_{2}^{\mathrm{I}} = \sum_{p=1,2} F^{\mathrm{I}(p)} U_{2}^{\mathrm{I}(p)} \text{ and } U_{2}^{\mathrm{II}} = \sum_{p=1,2} F^{\mathrm{II}(p)} U_{2}^{\mathrm{II}(p)}$$
(13)

and equality of the normal components of the stress tensor, $T_{32}^{I} = T_{32}^{II}$, where

$$T_{32}^{I} = \sum_{p=1,2} F^{I(p)} \left[C_{44}^{I} k_{3}^{I(p)} U_{2}^{I(p)} + e_{34}^{I} k_{3}^{I(p)} U_{4}^{I(p)} \right]$$

$$T_{32}^{II} = \sum_{p=1,2} F^{II(p)} \left[C_{44}^{II} k_{3}^{II(p)} U_{2}^{II(p)} + e_{34}^{II} k_{3}^{II(p)} U_{4}^{II(p)} \right]$$
(14)

Note that the superscripts "I" and "II" are for the first and second media, respectively. There are two electrical boundary conditions at $x_3 = 0$: continuity of the normal component D_3 of the electrical displacements, where

$$D_{32}^{I} = \sum_{p=1,2} F^{I(p)} \left[e_{34}^{I} k_{3}^{I(p)} U_{2}^{I(p)} - g_{33}^{I} k_{3}^{I(p)} U_{4}^{I(p)} \right]$$
$$D_{32}^{II} = \sum_{p=1,2} F^{II(p)} \left[e_{34}^{II} k_{3}^{II(p)} U_{2}^{II(p)} - g_{33}^{II} k_{3}^{II(p)} U_{4}^{II(p)} \right]$$
(15)

and continuity of the electrical potential $U_4 = \phi (\phi^{I} = \phi^{II})$ where

$$\phi^{\mathrm{I}} = \sum_{p=1,2} F^{\mathrm{I}(p)} \phi^{\mathrm{I}(p)}$$
 and $\phi^{\mathrm{II}} = \sum_{p=1,2} F^{\mathrm{II}(p)} \phi^{\mathrm{II}(p)}$ (16)

Therefore, the boundary-condition determinant (BCD4) of fourth-order for the interfacial waves can be written using the following four homogeneous equations:

$$\begin{pmatrix} U_{2}^{I(1)} & U_{2}^{I(2)} & -U_{2}^{II(1)} & -U_{2}^{II(2)} \\ C_{44}^{I}k_{3}^{I(1)}U_{2}^{I(1)} + & C_{44}^{I}k_{3}^{I(2)}U_{2}^{I(2)} + & -C_{44}^{I}k_{3}^{II(1)}U_{2}^{II(1)} - & -C_{44}^{II}k_{3}^{II(2)}U_{2}^{II(2)} - \\ e_{34}^{I}k_{3}^{I(1)}U_{4}^{I(1)} & e_{34}^{I}k_{3}^{I(2)}U_{4}^{I(2)} & e_{34}^{I}k_{3}^{II(1)}U_{4}^{II(1)} & e_{34}^{I}k_{3}^{II(2)}U_{4}^{II(2)} \\ U_{4}^{I(1)} & U_{4}^{I(2)} & -U_{4}^{II(1)} & -U_{4}^{II(2)} \\ e_{34}^{I}k_{3}^{I(1)}U_{2}^{I(1)} - & e_{34}^{I}k_{3}^{I(2)}U_{2}^{I(2)} - & -e_{34}^{II}k_{3}^{II(1)}U_{2}^{II(1)} + & -e_{34}^{I}k_{3}^{II(2)}U_{2}^{II(2)} + \\ g_{33}^{I}k_{3}^{I(1)}U_{4}^{I(1)} & g_{33}^{I}k_{3}^{I(2)}U_{4}^{I(2)} & g_{33}^{II}k_{3}^{II(1)}U_{4}^{II(1)} & g_{33}^{II}k_{3}^{II(2)}U_{4}^{II(2)} \end{pmatrix} \begin{pmatrix} F^{(1)} \\ F^{(2)} \\ F^{(3)} \\ F^{(4)} \end{pmatrix} = \begin{pmatrix} 0 \\ 0 \\ 0 \\ 0 \\ 0 \end{pmatrix}$$

$$(17)$$

Using the mechanical and electrical boundary conditions at $x_3 = 0$ such as $U_2^{I} = U_2^{II}$, $\sigma_{32}^{I} = \sigma_{32}^{II}$, $\phi^{I} = 0$ and $\phi^{II} = 0$, the

BCD4 of the coefficient matrix for the case of metallized interface can be obtained from the following equations:

$$\begin{pmatrix} U_{2}^{\mathrm{I}(1)} & U_{2}^{\mathrm{I}(2)} & -U_{2}^{\mathrm{II}(2)} \\ C_{44}^{\mathrm{I}}k_{3}^{\mathrm{I}(1)}U_{2}^{\mathrm{I}(1)} + & C_{44}^{\mathrm{I}}k_{3}^{\mathrm{II}(2)}U_{2}^{\mathrm{I}(2)} + & -C_{44}^{\mathrm{II}}k_{3}^{\mathrm{II}(1)}U_{2}^{\mathrm{II}(1)} - & -C_{44}^{\mathrm{II}}k_{3}^{\mathrm{II}(2)}U_{2}^{\mathrm{II}(2)} - \\ e_{34}^{\mathrm{I}}k_{3}^{\mathrm{II}(1)}U_{4}^{\mathrm{II}(1)} & e_{34}^{\mathrm{I}}k_{3}^{\mathrm{II}(2)}U_{4}^{\mathrm{II}(2)} & e_{34}^{\mathrm{II}}k_{3}^{\mathrm{III}(2)}U_{4}^{\mathrm{II}(2)} \\ U_{4}^{\mathrm{II}(1)} & U_{4}^{\mathrm{II}(2)} & 0 & 0 \\ 0 & 0 & U_{4}^{\mathrm{III}(1)} & U_{4}^{\mathrm{II}(2)} \end{pmatrix} \begin{pmatrix} F^{(1)} \\ F^{(2)} \\ F^{(3)} \\ F^{(4)} \end{pmatrix} = \begin{pmatrix} 0 \\ 0 \\ 0 \\ 0 \\ 0 \end{pmatrix}$$
(18)

The complete mechanical displacement U_2^{Σ} and electrical potential $\varphi^{\Sigma} = U_4^{\Sigma}$ are written for each half-space as follows:

$$U_{2,4}^{\Sigma} = \sum_{p=1,2} F^{(p)} U_{2,4}^{0(p)} \exp\left[jk\left(n_1 x_1 + n_3^{(p)} x_3 - V_{ph}t\right)\right]$$
(19)

The corresponding weight functions $F^{(p)}$ are found from Equations (17) and (18), which can give the same eigenvectors $(U_2^{0(1)}, U_4^{0(1)})$ and $(U_2^{0(2)}, U_4^{0(2)})$ for two equal eigenvalues $n_3^{(1)} = n_3^{(2)}$ in each half-space and hence $F^{(1)} = -F^{(2)}$. It is obvious that the weight factors $F^{(1)} = -F^{(2)}$ will zero the complete mechanical displacement U_2^{Σ} and electrical potential φ^{Σ} in Equations (17) and (18). That can mean that they are "latent" characteristics. On the other hand, eigenvalues $n_3^{(1)} \neq n_3^{(2)}$ give corresponding eigenvectors $(U_2^{0(1)}, U_4^{0(1)})$ and $(U_2^{0(2)}, U_4^{0(2)})$ as well as $F^{(1)} \neq -F^{(2)}$ resulting in non-zero displacements, which must be equal at the interface damping towards the depth of both media.

4. Results and Discussions

Acoustic wave propagation along the common interface between two dissimilar piezoelectric materials has peculiarities concerning choice of suitable materials to support the SH-waves. Maerfeld and Tournois in Ref. [1] have found that the interfacial SH-waves can always exist in suitable cuts of the transversely-isotropic materials, in which the surface BG-waves can also exist. Note that the velocity of interfacial Maerfeld-Tournois (MT) wave in similar materials with opposite polarization coincides with the velocity V_{BGm} of the surface BG-wave propagating along the metallized surface of transversely-isotropic piezoelectrics, $V_{BGm} = V_{SH} [1 - (K_e^2/(1 + K_e^2))^2]^{1/2} [2]$. This can mean that some similarity occurs between the interfacial MT-waves and surface BG-waves when the transversely-isotropic materials are treated. The velocity V_{BG} of the BG-wave with the non-metallized surface is calculated with the following formula: $V_{BG} = V_{SH} \{1 - (K_e^2/[(1 - K_e^2/[(1 - K_e^2/[($ $(+K_e^2)(1 + g_{11}/g_0))^2$ ^{1/2}. Due to the fact that the surface Bg-waves and the interfacial MT-waves cannot exist in piezoelectric cubic crystals, the existence of new surface SH-waves called the ultrasonic surface Zakharenko waves (USZWs) was studied in the cubic crystals (see Ref. [10]) and the new interfacial SH-wave existence is

studied in this paper. The material constants and USZW characteristics for several cubic crystals with strong piezoelectric effect are listed in **Tables 1** and **Table 2**, respectively. It was found that the velocities of the new interfacial waves with metallized interface are coincide with the V_{BGm} . This is also true for the velocities of the interfacial MT-waves and the USZWs on the metallized surface. That illuminates common wave speed characteristics among the different waves. Therefore, they can be calculated with the for mula for V_{BGm} written above. It is noted that all the above mentioned velocities were calculated using different boundary-condition determinants. However, it was found that the velocity of the USZWs on the non-metallized surface cannot be calculated with the formula for V_{BG} . For instance, the formula for V_{BG} gives the value of $V_1 \sim$ 848.6 m/s instead of the **Table 2** value of $V_{new} \sim 848.1$ m/s for Tl₃TaSe₄. The velocity V_1 is significantly closer to the velocity v_{SH} of bulk waves (see **Table 2**) than the true velocity V_{new} obtained numerically. Therefore, it is obvious that the penetration depth of the USZWs in piezoelectric cubic crystals will be smaller than that for the BG-waves in the transversely-isotropic surface monocrystals. This is an advantage of the USZWs. Note that all the wave characteristics were calculated with an accuracy of about 1 µm/s. This is useful and allows the distinguishing of V_{ph} -solutions when they are close to each other.

Figure 2 shows the phase velocity solutions for the new interfacial waves (V_{in}) in the Chalcogenides Tl₃TaSe₄ and Tl₃VS₄ pertaining to class $\overline{43m}$, $V_{in} = V_{new,m}$, using similar materials for the acoustic systems with opposite polarization and both the metallized and non-metallized interfaces, $V_{in} = V_{in,m}$. The finding of V_{in} for the cubic crystals Bi₁₂SiO₂₀ and Bi₁₂GeO₂₀ of class 23 is shown in **Figure 3** using the same configuration consisting of

Table 1. The material constants: the material density ρ , non-zero elastic C_{44} , piezoelectric e_{14} and dielectric g_{11} constants for the SH-wave propagation in the piezoelectric cubic crystals [7,8,9] with the strong piezoelectric effect. Note that the dielectric constant of a vacuum is $g_0 = 0.08854 [10^{-10} \text{ F/m}]$; $e_{16}^{[101]} = -e_{14}^{[100]}$ and $e_{34}^{[101]} = e_{14}^{[100]}$. The coefficient of electromechanical coupling (CEMC) K_e^2 in the last column was calculated with the following formula: $K_e^2 = e_{14}^2/(C_{44}g_{11})$.

Material	Density, ρ [kg/m ³]	$C_{44}, 10^{10} [\text{N/m}^2]$	$e_{14}^{[100]}$ [C/m ²]	g_{11}/g_0	K_e^2
Tl_3TaSe_4 (43 m)	7280	0.410	0.320	10.1	0.2793
Tl ₃ VS ₄ (43 m)	6140	0.470	0.550	34.8	0.2089
Bi ₁₂ TiO ₂₀ (23)	11200	2.600	1.100	47.0	0.1118
Bi ₁₂ SiO ₂₀ (23)	9070	2.451	1.122	41.1	0.1412
Bi ₁₂ GaO ₂₀ (23)	9300	2.600	1.100	145.7	0.0361
$Bi_{12}GeO_{20}(23)$	9200	2.562	0.983	37.7	0.1131

Table 2. The wave characteristics: the velocities V_{K} , V_{t4} , and V_{SH} (all in m/s) as well as the velocities V_{new} and $V_{new,m}$ of the new-SH-SAWs (USZWs) on the free and metallized surfaces, respectively, for the piezoelectric cubic crystals with the strong piezoelectric effect when the wave propagation is along direction [101]. The last column lists the non-dimensional values of the CEMC K^2 calculated with formula (20). Note that one can calculate that $V_{BG}(Bi_{12}SiO_{20}) = 1756.096654$ m/s is larger than $V_{new}(Bi_{12}SiO_{20})$ and the same occurs for $V_{BG}(Bi_{12}GeO_{20}) = 1760.569112$ m/s.

Material	V_K	V_{t4}	V_{SH}	V_{new}	$V_{new,m}$	K^2
$Tl_3TaSe_4(\overline{4}3m)$	846.9869546	750.4577358	848.8104580	848.125556	828.335498	0.047
$Tl_3VS_4(\overline{4}3m)$	948.1841318	874.9127458	961.9607843	961.927246	947.491302	0.030
Bi12TiO20 (23)	1495.282953	1523.62350	1606.562692	1606.556882	1598.414906	0.010
Bi12SiO20 (23)	1677.148081	1643.872053	1756.104245	1756.089613	1742.609095	0.015
Bi12GaO20 (23)	1326.112526	1672.034367	1701.927576	1701.927574	1700.895518	0.001
Bi12GeO20 (23)	1640.769006	1668.766793	1760.575183	1760.565157	1751.469403	0.010



Figure 2. The dependence of the boundary-condition determinants (BCD4) on the phase velocity V_{ph} for direction [101] of the new interfacial wave (V_{in}) propagation in the systems Tl₃TaSe₄ (a) and Tl₃VS₄ (b) with opposite polarization using the interface metallization (mBCD4) and non-metallized interface (BCD4).



Figure 3. The dependence of the boundary-condition determinants (BCD4) on the phase velocity V_{ph} for direction [101] of the new interfacial wave (V_{in}) propagation in the systems $Bi_{12}SiO_{20}$ and $Bi_{12}GeO_{20}$ with opposite polarization using the interface metallization (mBCD4) and non-metallized interface (BCD4).

similar materials. It was thought that the crystals $Bi_{12}SiO_{20}$ and $Bi_{12}GeO_{20}$ can be used together to support propagation of the new interfacial waves in dissimilar

material, because their bulk SH velocities v_{SH} are relatively close to each other and also true for V_{in} . The BCD4 behaviors for the dissimilar materials are shown in Figure 4, in which it is clearly seen that there are solutions for the Bi₁₂SiO₂₀/Bi₁₂GeO₂₀ configuration. Using the normal polarization for the crystals $Bi_{12}SiO_{20}$ and $Bi_{12}GeO_{20}$, only the velocity $V_{in,m}$ for the metallized interface was found having the value of $V_{in,m}$ = 1746.926119 m/s. The $V_{in,m}$ value is larger than the value of $V_{new,m}$ for Bi₁₂SiO₂₀ listed in **Table 2** and smaller than the value of $V_{new,m}$ for Bi₁₂GeO₂₀. However, the configuration with the opposite-polarized crystals Bi12SiO20 and $Bi_{12}GeO_{20}$ demonstrates existence of both velocities $V_{in,m}$ and V_{in} for the metallized and non-metallized interfaces, $V_{in.m} = 1746.926119$ m/s and $V_{in} = 1747.138149$ m/s. It is clearly seen that the values of $V_{in,m}$ and V_{in} are close to each other but distinguishable in the calculations.

In the case of known values of the $V_{in,m}$ and V_{in} , the existence of the new interfacial waves for both the electrical boundary conditions allows evaluation of the coefficient of electromechanical coupling (K^2):

$$K^{2} = 2 \frac{V_{in} - V_{in,m}}{V_{in}}$$
(20)

The value of K^2 calculated with formula (20) is very small for the crystals with the strong piezoelectric effect (see the tables) and is equal to $K^2 \sim 0.000243$. This is only ~ 0.0243% and significantly smaller than ~ 1% for Bi₁₂GeO₂₀ listed in **Table 2**. It is also noted that the interfacial wave propagation can be studied in suitable two-layer structures consisting of various cubic piezomagnetics [17,18]. Note that a study of interfacial wave propagation in non-cubic piezomagnetics was recently introduced in Ref. [19].



Figure 4. The dependence of the boundary-condition determinants (BCD4) on the phase velocity V_{ph} for direction [101] of the new interfacial wave $(V_{in,m})$ propagation in the Bi₁₂SiO₂₀/Bi₁₂GeO₂₀ systems with normal (bold lines) and opposite polarization (normal lines) using the interface metallization (mBCD4) and non-metallized interface (BCD4).

5. Conclusions

This theoretical report was concerned with the interfacial wave propagation in cubic crystals with strong piezoelectric effect, in which the surface Bleustein-Gulyaev waves cannot exist. This was recently mentioned in Ref. [5] by Gulyaev and Hickernell. It was illuminated that the new interfacial waves can always be found in acoustic systems consisting of two half-spaces representing identical materials with opposite polarization. Also, the new interfacial waves can exist in dissimilar materials solidly coupled at their interface, for instance, in the Bi₁₂SiO₂₀/Bi₁₂GeO₂₀ system, using the electrical boundary conditions of both the metallized and non-metallized interfaces. Note that the theoretically obtained results can be useful to design experiments for measuring interfacial properties by the microwave technologies.

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